

Vibration damping of structures coupled to passive piezoelectric networks

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Georgia Institute of Technology

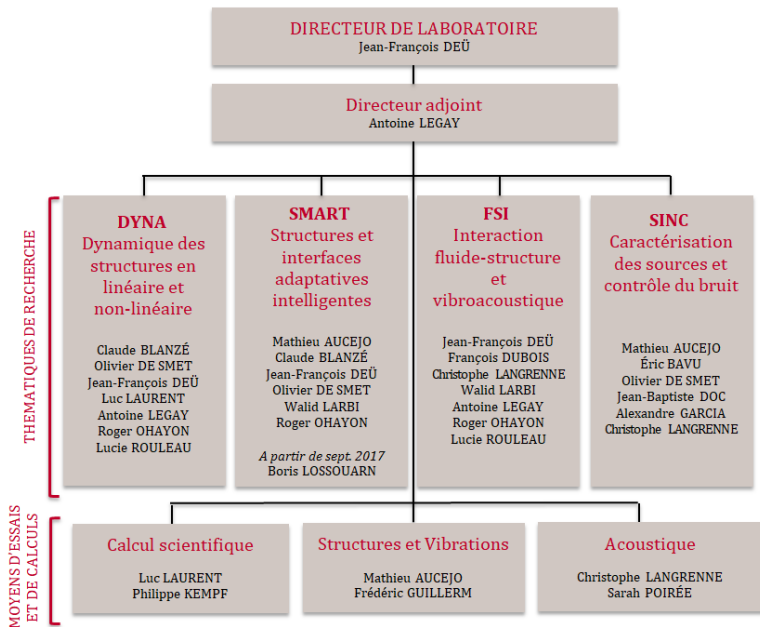
University of Liège

École Navale...

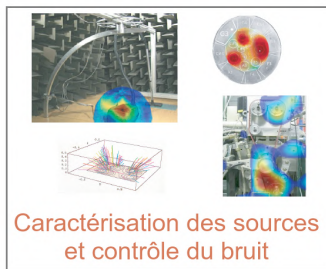
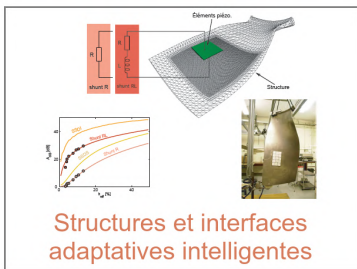
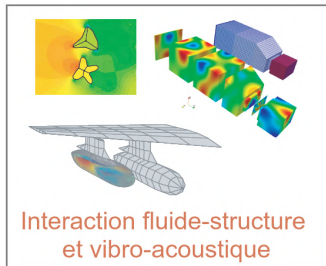
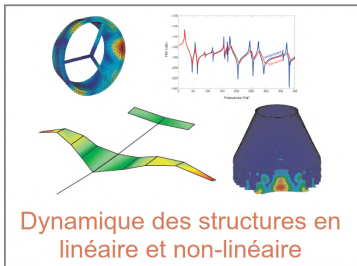
Séminaire du département Mécatronique, ENS Rennes, 11 février 2020

le **cnam**

Laboratoire de Mécanique des Structures et Syst. Couplés



Thématiques de recherche du LMSSC



Projets et collaborations

- ▷ Projets industriels
 - ▶ ARIANE GROUP, SAFRAN, AIRBUS, NAVAL GROUP...

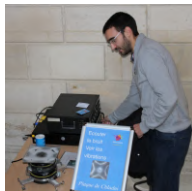
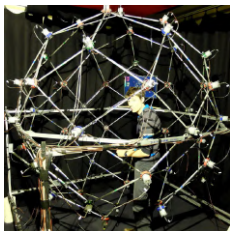
- ▷ Collaborations recherche avec
 - ▶ des laboratoires de recherche en France
 - ▶ des laboratoires de recherche à l'étranger
 - ▶ des organismes de recherche : DGA, CNES, CSTB, ...

- ▷ Projets transverses avec des partenaires d'autres disciplines
 - ▶ Modélisation mécanique pour l'archéologie virtuelle : restitution d'un char celtique à deux roues - Coll. avec le Musée d'Archéologie de Saint-Germain

Organisation d'évènements pour le grand public

▷ Quelques exemples:

- ▶ Nuit européenne des musées : Immersion sonore 3D
- ▶ Fêtes de la science avec le Musée des arts et métiers :
Conception d'un aéronef; Bruit et vibrations : du réel au virtuel; ...



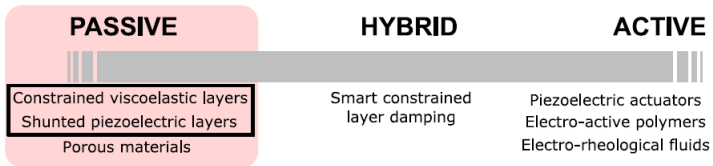
Outline

- 1 Laboratoire de Mécanique des Structures et des Systèmes Couplés
- 2 Piezoelectric tuned vibration absorber
- 3 Finite element models and optimization for complex structures
- 4 Environmental parameters: beyond the linear shunt
- 5 Multimodal vibration damping
- 6 Conclusions and perspectives

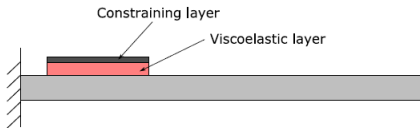
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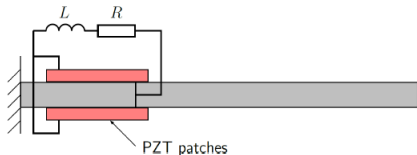
Passive vibration mitigation



- Constrained viscoelastic patches



- Piezoelectric patches connected to an electrical network

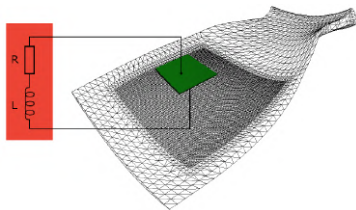


(👉 Lucie Rouleau)

Piezoelectric damping offers great perspectives

Vibration reduction for structural integrity and increased lifespan

→ Ex.: Turbofan engine (📖 S n chal, 2011 + Thierry, 2016 / Safran)



Piezoelectric patch connected to a passive electrical circuit

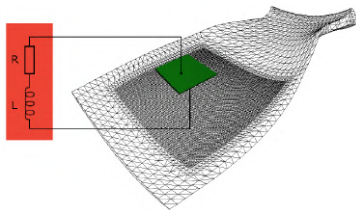
→ Resonant shunt = Inductor + Resistor (📖 Hagood & von Flotow, 1991)

→ Electrical resonance tuned to a single and linear mechanical mode

Piezoelectric damping offers great perspectives

Vibration reduction for structural integrity and increased lifespan

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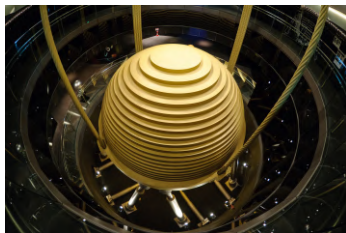
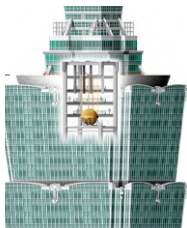
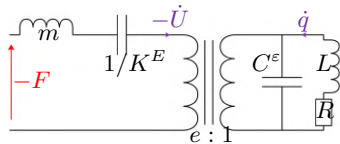
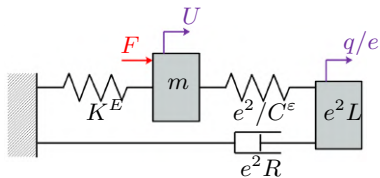


Piezoelectric patch connected to a **passive electrical circuit**

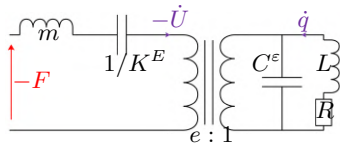
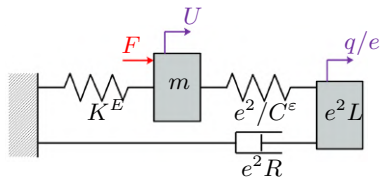
→ **Resonant shunt** = Inductor + Resistor (📄 Hagood & von Flotow, 1991)

→ Electrical resonance tuned to a **single and linear mechanical mode**

Electromechanical Tuned Mass Damper



Electromechanical Tuned Mass Damper



$$\Rightarrow \left(\frac{U}{F}\right)_{\text{adim.}} = \frac{1 + 2j \frac{\xi_e}{\Omega_e} \Omega - \left(\frac{\Omega}{\Omega_e}\right)^2}{\left[1 - \left(\frac{\Omega}{\Omega_o}\right)^2\right] \left[1 + 2j \frac{\xi_e}{\Omega_e} \Omega - \left(\frac{\Omega}{\Omega_e}\right)^2\right] - \frac{k_{c0}^2}{1 + k_{c0}^2}}$$

Coupling coefficient k_{c0}

Mechanical resonance Ω_o

Electrical damping ξ_e

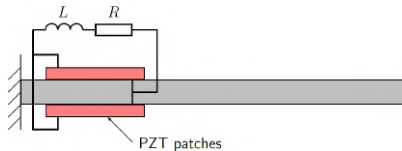
Electrical resonance $\Omega_e = \frac{1}{\sqrt{LC^\epsilon}}$

Tuning of the resonant shunt

Transfer function criterion:

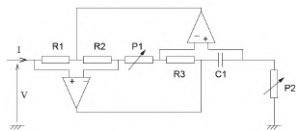
$$(\Omega_e)_{\text{opt}} = \Omega_o$$

$$(\xi_e)_{\text{opt}} = \sqrt{\frac{3}{8}} k_c$$



Several solutions to obtain large inductance values

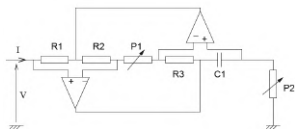
Synthetic inductor with analog circuit (Antoniou, 1969)



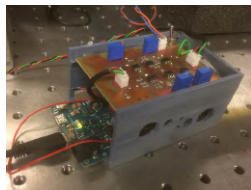
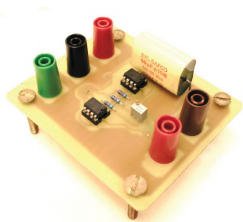
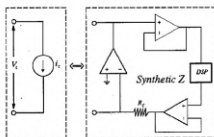
$$j\omega C_1 P_2 R_3 \frac{R_1}{R_2} - P_1 \frac{R_1}{R_2}$$

Several solutions to obtain large inductance values

Synthetic inductor
with analog circuit
(Antoniou, 1969)



Synthetic impedance
with digital controller
(Fleming, 2002)

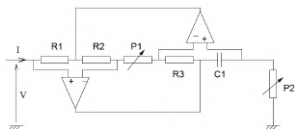


$$j\omega C_1 P_2 R_3 \frac{R_1}{R_2} - P_1 \frac{R_1}{R_2}$$

$$Z(\omega)$$

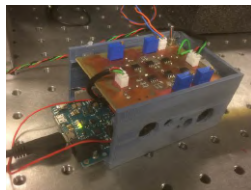
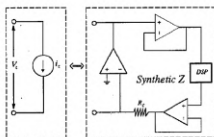
Several solutions to obtain large inductance values

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$$j\omega C_1 P_2 R_3 \frac{R_1}{R_2} - P_1 \frac{R_1}{R_2}$$

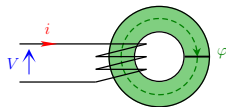
Synthetic impedance with digital controller (Fleming, 2002)



$$Z(\omega)$$

Passive inductor with magnetic core

Sensors & Actuators, 2017



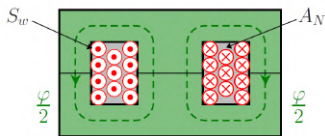
up to 1000 H !

$$j\omega L_{eq}(\omega) + R_{eq}(\omega)$$

Electrical components with high quality factors

Resonant shunt → **Specifications on L and R**

Restriction on the available room



Window utilization factor

$$k_u = \frac{NS_w}{A_N} \approx 0.5 \text{ when full}$$

Magnetic cores with high permeance ($A_L \geq 10 \mu\text{H}$)

→ **Cores in ferrite or Nanocrystalline toroids** (Vitroperm 500F)



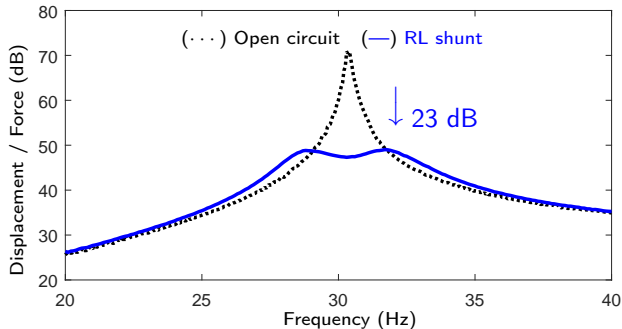
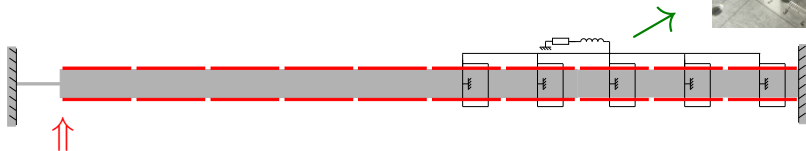
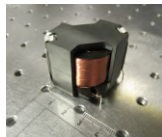
+ **Energy** considerations...

Resonant shunts can be implemented with passive inductors

Realization with a **magnetic core** in ferrite (100 H)

→ [B. Lossouarn, M. Aucejo, J.-F. Deü, B. Multon, Sensors & Actuators A, 2017](#)

→ $C = 250 \text{ nF} \Rightarrow L = 100 \text{ H}$ & $R = 3\text{k}\Omega$



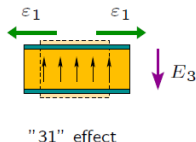
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From linear piezoelectricity to a finite element model

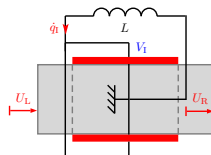
▷ Constitutive law :

$$\begin{cases} \sigma_i = c_{ij}^E \varepsilon_j - e_{ji} E_j \\ D_i = e_{ij} \varepsilon_j + \epsilon_{ij}^E E_j \end{cases}$$



- c_{ij}^E : stiffness const. (with constant E)
- e_{ij} : piezoelectric const.
- ϵ_{ij}^E : permittivity (with constant ε)

Mass, Stiffness and Coupling matrices



$$\begin{pmatrix} \mathbf{M}_m & \mathbf{0} \\ \mathbf{0} & \mathbf{0} \end{pmatrix} \begin{pmatrix} \ddot{\mathbf{U}} \\ \ddot{\mathbf{V}} \end{pmatrix} + \begin{pmatrix} \mathbf{K}_m & \mathbf{K}_c \\ -\mathbf{K}_c^\top & \mathbf{K}_e \end{pmatrix} \begin{pmatrix} \mathbf{U} \\ \mathbf{V} \end{pmatrix} = \begin{pmatrix} \mathbf{F} \\ \mathbf{Q} \end{pmatrix}$$

+ Shunt impedance equation: $V = \omega^2 LQ$

Coupling coefficient from open- and short-circuit conditions

▷ $V = 0$, short-circuit

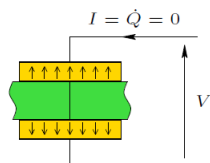
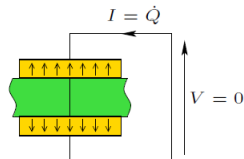
$$\mathbf{M}_m \ddot{\mathbf{U}} + \mathbf{K}_m \mathbf{U} = \mathbf{0}$$

$\rightsquigarrow (\omega_{SC,i}, \hat{\Phi}_{SC,i})$, short-circuit (sc) eigenmodes

▷ $Q = 0$, open-circuit

$$\mathbf{M}_m \ddot{\mathbf{U}} + (\mathbf{K}_m + \mathbf{K}_e \mathbf{K}_e^{-1} \mathbf{K}_e^T) \mathbf{U} = \mathbf{0}$$

$\rightsquigarrow (\hat{\omega}_{OC,i}, \hat{\Phi}_{OC,i})$, open-circuit (oc) eigenmodes



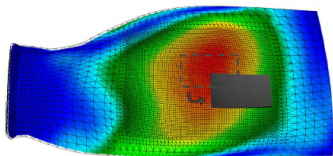
Performance and electrical tuning directly related to the **coupling coefficient**

$$k_c = \sqrt{\frac{\omega_{OC}^2 - \omega_{SC}^2}{\omega_{SC}^2}} \Rightarrow L = \frac{1}{C\omega_O^2} \quad \text{and} \quad R = \sqrt{\frac{3}{2}} \frac{k_c}{C\omega_O}$$

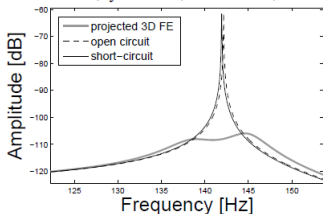
Optimization for maximizing the coupling coefficient

▷ Optimization results : 1B

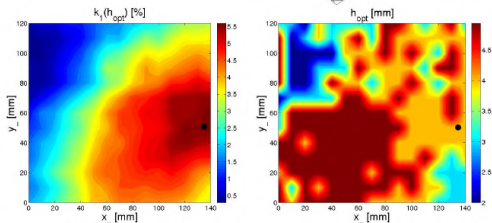
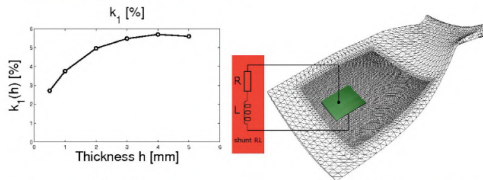
$P = 1$, fixed width and length



Mode 1B, $\xi=0.0001$, $R=8429 \Omega$, $L=136 \text{ H}$



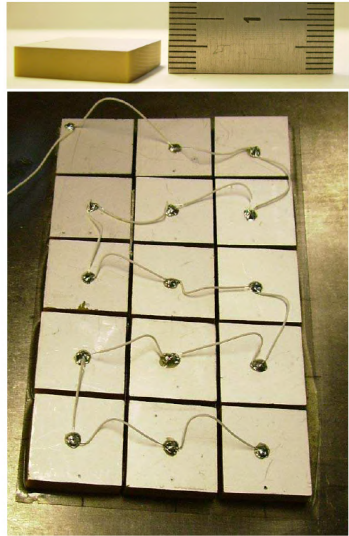
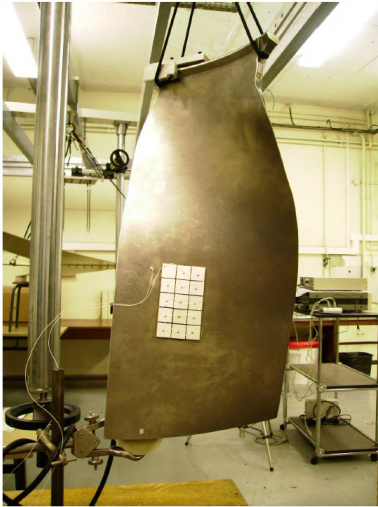
▷ Exhaustive search : 1B



(S en echal, 2011)

Current developments : uncoupled optimization for thin piezoelectric patches

First experiments on titanium blades (CFM56)



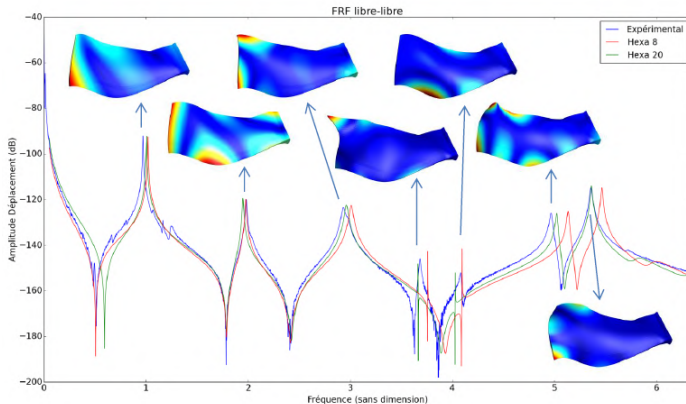
Proof of concept for piezoelectric damping of an industrial structure (-24 dB)

Extension to woven carbon-epoxy fan blades (LEAP)

Mode shapes identification to define
positioning of thin PZT patches

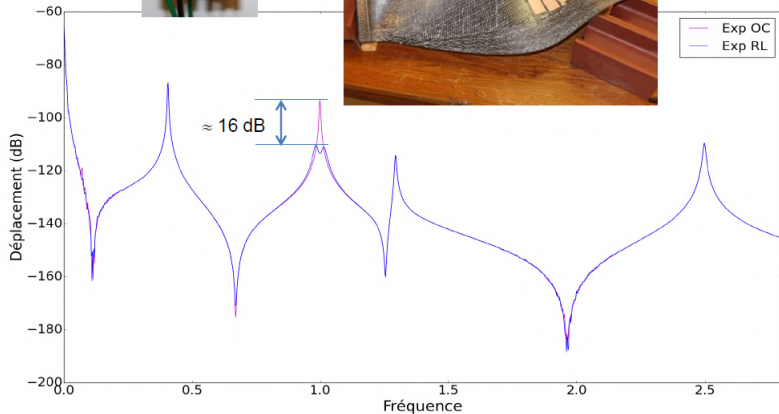


( Thierry, 2016)



Experimental validation of vibration mitigation performance

With purely passive inductance



Significant damping with less than 1% mass addition (PZT = 0.2 mm)

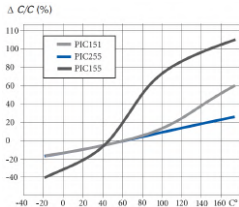
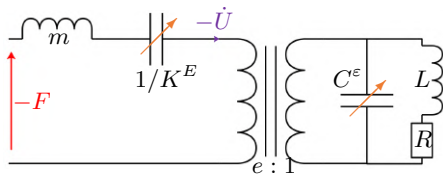
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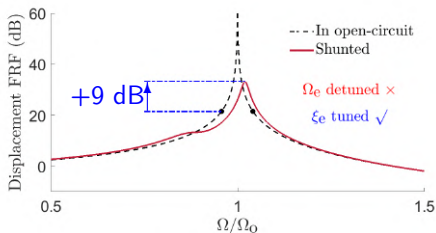
Temperature has a non-negligible influence

In case of temperature variations:

$$\Omega_e(T) = \Omega_o(T)$$



Datasheets: P.I. Ceramic

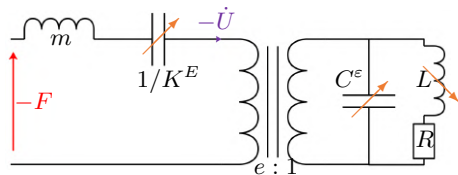


$$\Omega_e = 0.9 \Omega_o$$

$$\xi_e = (\xi_e)_{opt}$$

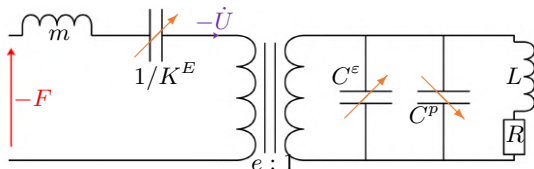
$$k_{c0} = 0.12$$

Using a variable inductance or a variable capacitance ?



Tuning condition: $\Omega_0^2(T) = \frac{1}{L(T)C^\varepsilon(T)}$

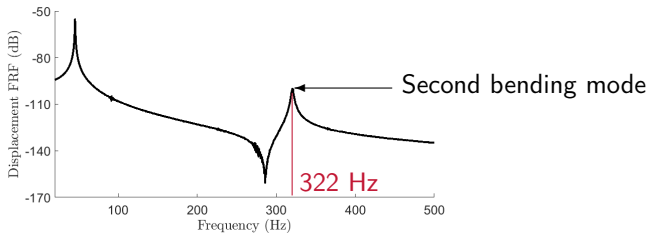
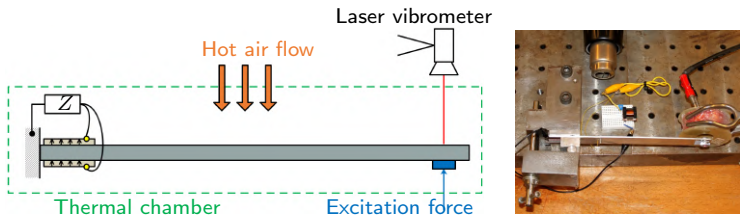
More details:  *R. Darleux et al., JSV, 2018*



Tuning condition: $\Omega_0^2(T) = \frac{1}{L[C^\varepsilon(T)+C^p(T)]}$

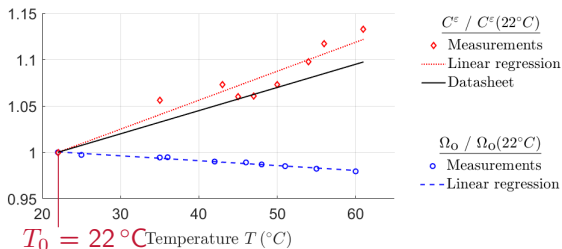
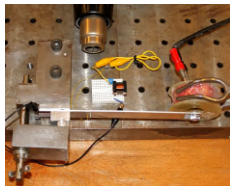
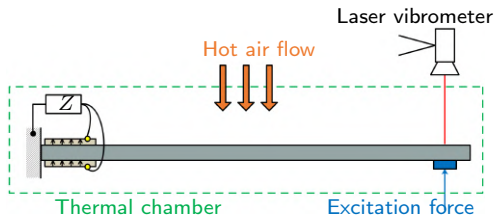
Experiments to extract temperature dependence

Temperature range: Room temperature: 22 °C \Rightarrow 60 °C



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Temperature range: Room temperature: 22 °C \Rightarrow 60 °C



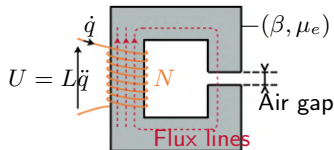
Design of passive inductors

$$L = \beta \mu_e N^2$$

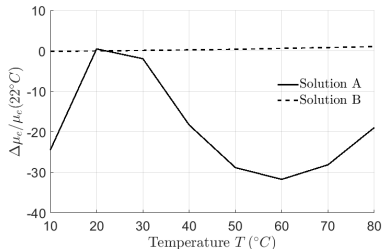
β : geometric constant

μ_e : effective magnetic permeability

N : turns



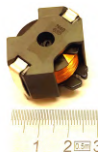
Datasheet: Epcos TDK



Solution A

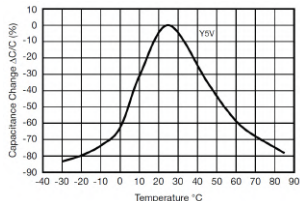


Solution B

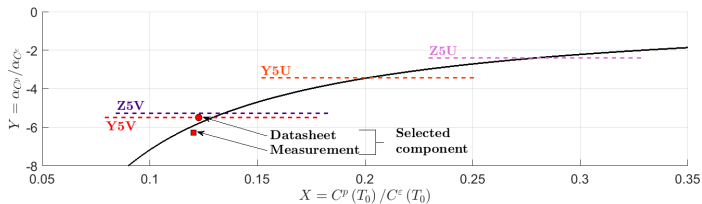


Choice of a variable capacitor

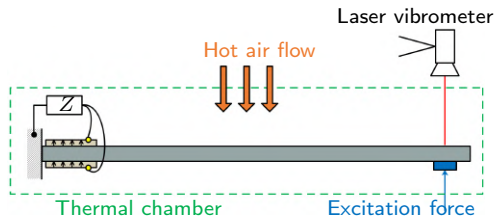
Datasheets: Vishay BCcomponents



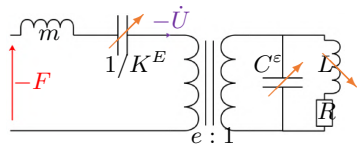
Class 2 ceramic capacitors
Existing dielectrics: Y5U, Y5V, Z5U,
Z5V...



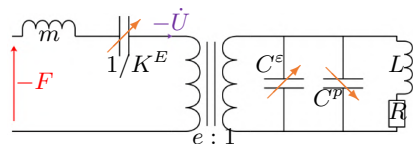
Vibration damping of a clamped beam



Solution A

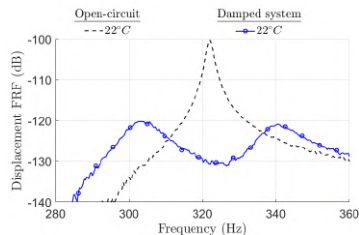


Solution B

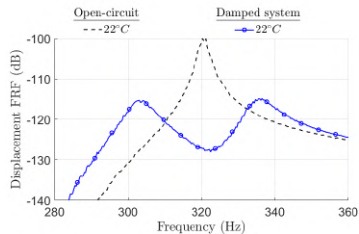


Comparison of adaptive resonant shunt solutions

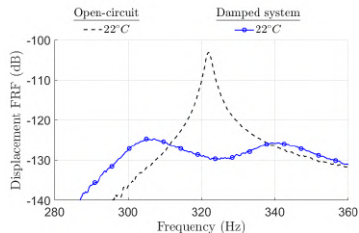
Solution A



Solution B

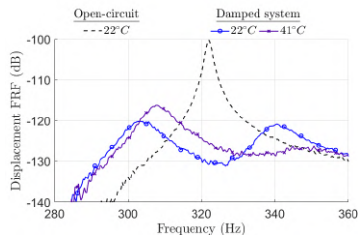


Without adaptive tuning

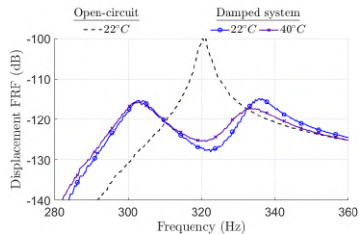


Comparison of adaptive resonant shunt solutions

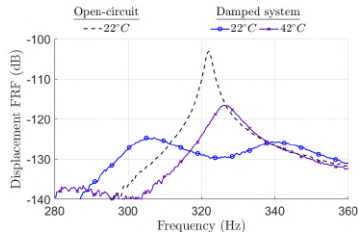
Solution A



Solution B

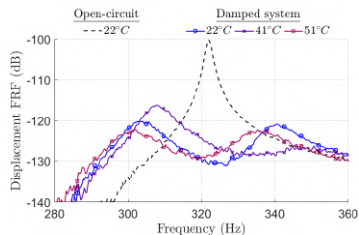


Without adaptive tuning

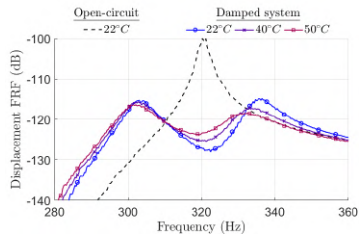


Comparison of adaptive resonant shunt solutions

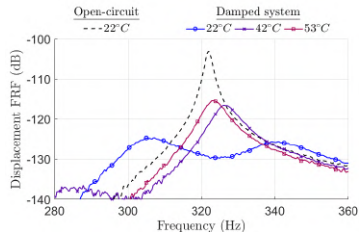
Solution A



Solution B

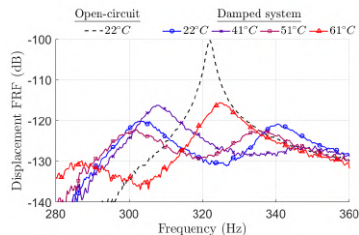


Without adaptive tuning

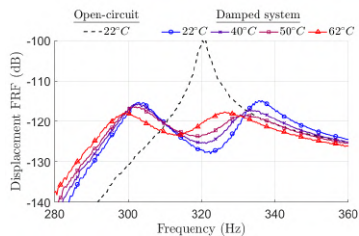


Comparison of adaptive resonant shunt solutions

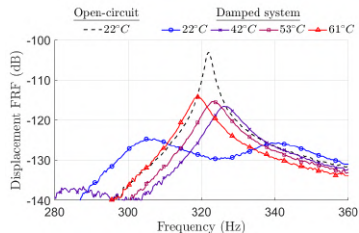
Solution A



Solution B

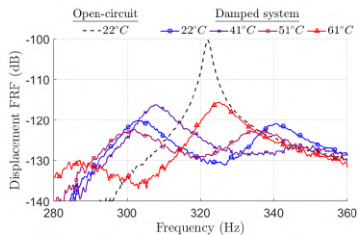


Without adaptive tuning

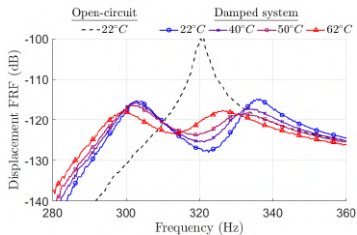


Comparison of adaptive resonant shunt solutions

Solution A

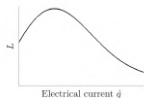


Solution B

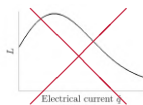


Damping performance maintained on a given temperature range

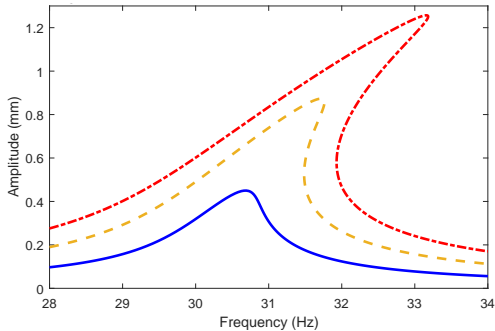
Excitation dependent tuning



Tuning \sim independent from the excitation



Most industrial structures are nonlinear



Objective of this study:
Linear + Nonlinear
"Mirror"

Multimodal & Nonlinear
Mechanical structure



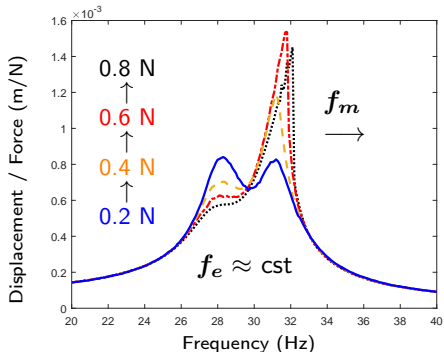
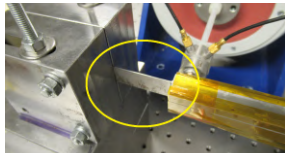
Multi-resonant & Nonlinear
Electrical network

Yet, nonlinearity strongly affects the performance

Thin lamina $\Rightarrow f \approx K_L u + K_{NL} u^3$

\rightarrow **Hardening nonlinearity**

\rightarrow **Detuning** of the resonant shunt



\rightarrow **Nonlinear piezoelectric tuned vibration absorber required !**

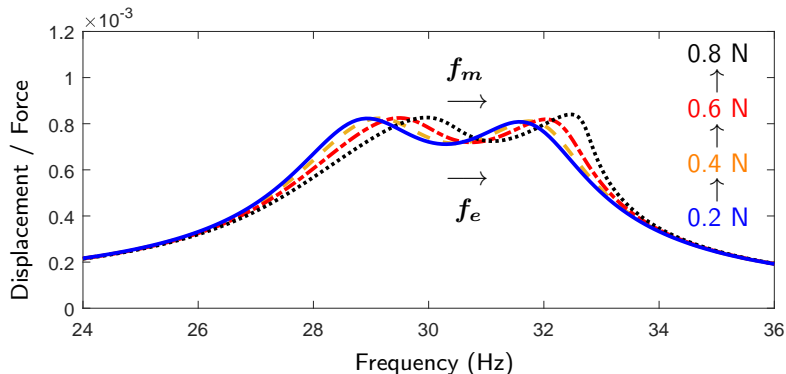
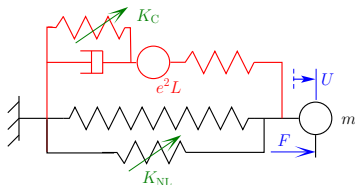
Similar nonlinearity in the absorber for global compensation

"Nonlinear + Nonlinear = Linear" (Habib, 2016)

Tuning rule (Soltani, 2015)

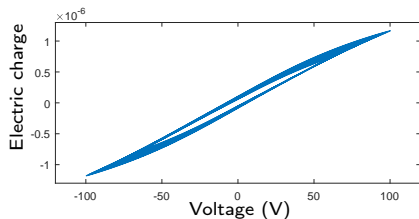
$$\rightarrow K_C \simeq 2 \left(\frac{e^2 L}{m} \right)^2 K_{NL}$$

for cubic nonlinearity



How to implement the nonlinearity in the electrical domain ?

Capacitor: $Q = CV$



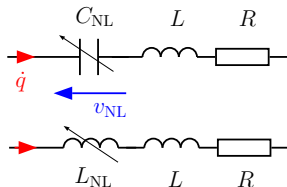
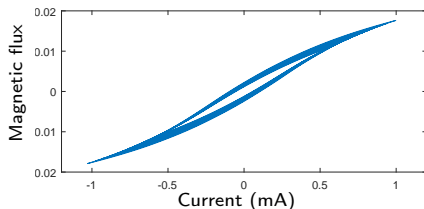
Nonlinear capacitance

$$C_{NL} = C^*/q^2 \Rightarrow v_{NL} \propto q^3$$

Nonlinear inductance

$$L_{NL} = -L^*\dot{q}^2 \Rightarrow v_{NL} \propto -\dot{q}^2\ddot{q}$$

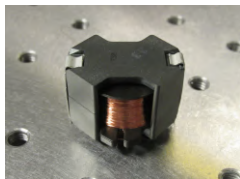
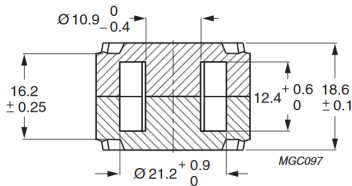
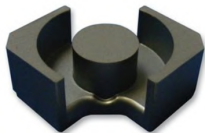
Inductor: $\Phi = L\dot{Q}$



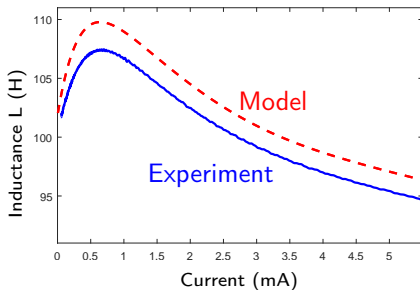
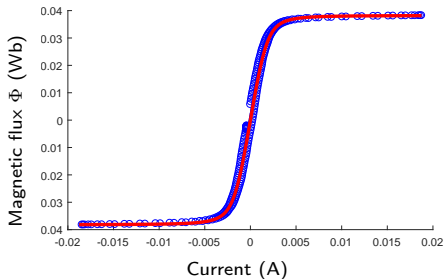
→ Same cubic voltage after one-term Harmonic Balance approximation

Inductor design from magnetic component theory

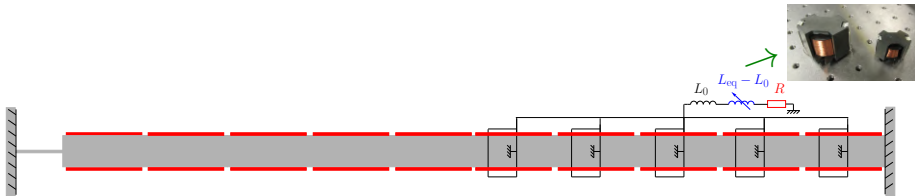
Magnetic saturation: Depends on material, geometry, number of turns...



Relation between total magnetic flux and electrical current $\Rightarrow \Phi = L\dot{Q}$

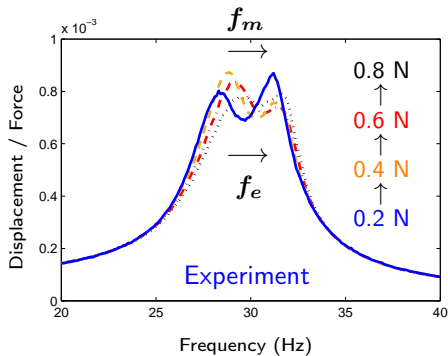


Intentional nonlinearity in the piezoelectric absorber



A fully passive solution:
Nonlinear inductor

→ Variation of the inductance value
due to **magnetic saturation**



→ [B. Lossouarn, J.-F. Deü, G. Kerschen, Philosophical Transactions of the Royal Society A, 2018](#)

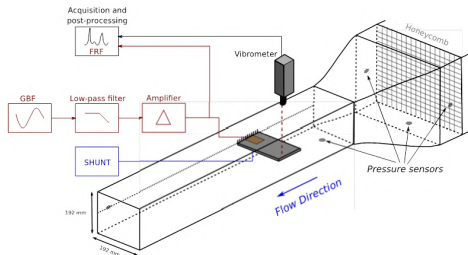
Flow-induced vibrations can have dramatic consequences



→ Structural and acoustic issues

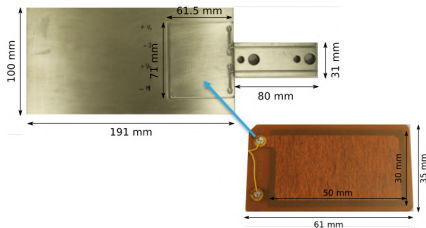
Hydrodynamic test facility at IRENav

Experimental setup:



- Cantilevered aluminium flat plate
- Incidence of 0°
- 2 patches on each side

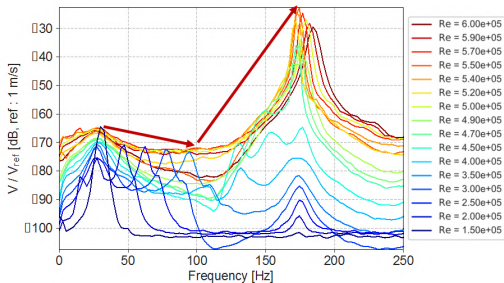
Geometry:



( Laetitia Pernod)

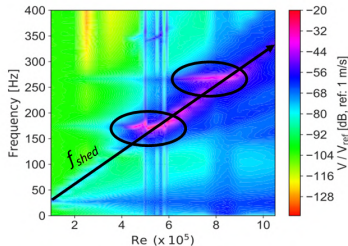
Vortex induced vibrations

Frequency response for different flow velocities:



- Natural frequencies observed
- Additional components with a strong dependence to the velocity

Von Kármán vortex shedding:



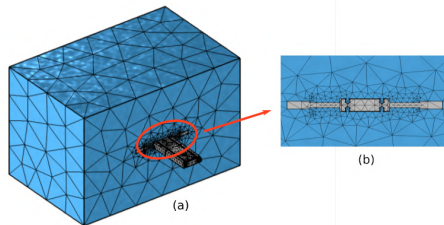
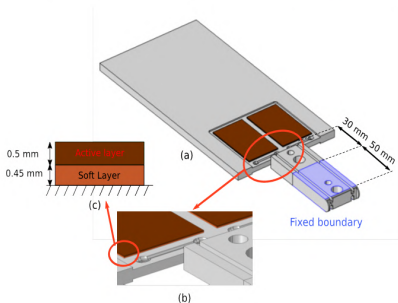
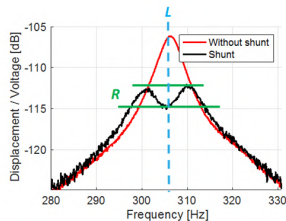
- Strouhal's law: $S_t = \frac{f_{shed} \cdot e}{U_0} \sim 0.2$

Numerical model involving surrounding fluid

Numerical simulation with
COMSOL Multiphysics

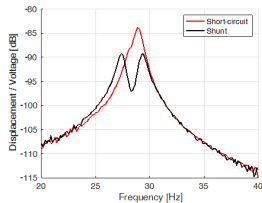
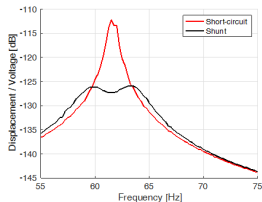
Structural model
+ Piezoelectricity + Acoustics

Natural frequencies
+ Coupling factors



Performance of the piezoelectric shunt

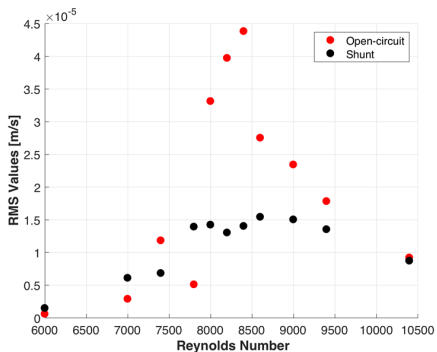
Damping using resonant shunt (1st bending mode)



In air

In still water

Vibration reduction under hydrodynamic flows

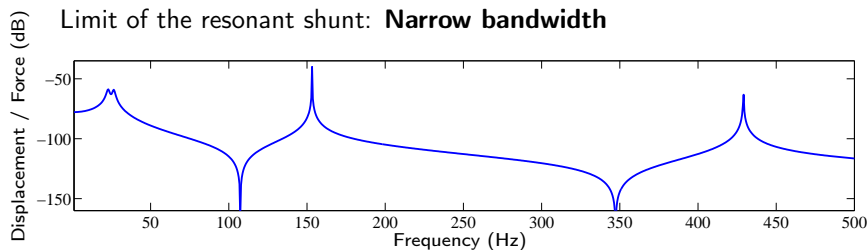


RMS value divided by 3

Outline

- 1 Laboratoire de Mécanique des Structures et des Systèmes Couplés
- 2 Piezoelectric tuned vibration absorber
- 3 Finite element models and optimization for complex structures
- 4 Environmental parameters: beyond the linear shunt
- 5 Multimodal vibration damping**
- 6 Conclusions and perspectives

Passive technique for multimodal damping ?



Interconnected array

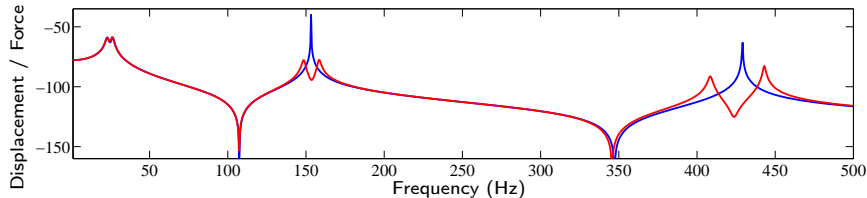
→ Multi-resonant network

Electrical analogue of the mechanical structure

→ Multimodal damping with a passive electrical network (↪ Porfiri, 2004)

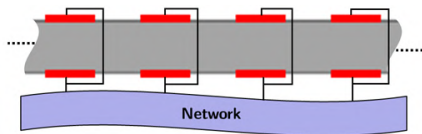
Passive technique for multimodal damping ?

Limit of the resonant shunt: **Narrow bandwidth**



Interconnected array

→ Multi-resonant network

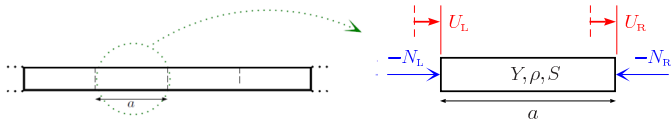


Electrical analogue of the mechanical structure

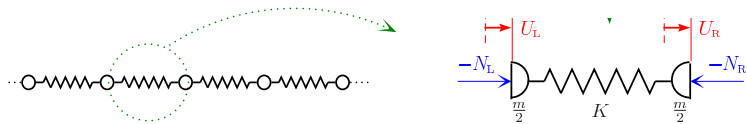
→ **Multimodal damping** with a passive electrical network (👉 Porfiri, 2004)

The analogous network is equivalent to the discrete model

Homogeneous rod for longitudinal wave propagation



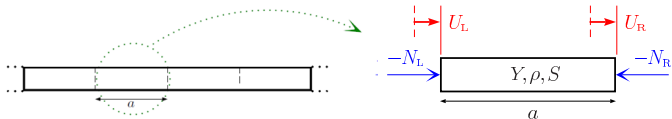
Corresponding **discrete structure** modeled by a lattice of point masses



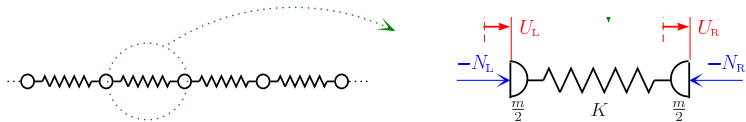
Analogous network involving capacitors and inductors (Direct analogy)

The analogous network is equivalent to the discrete model

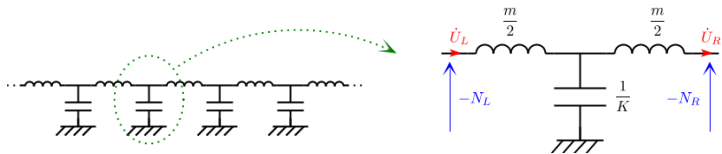
Homogeneous rod for longitudinal wave propagation



Corresponding **discrete structure** modeled by a lattice of point masses

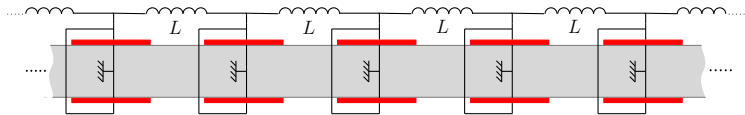


Analogous network involving capacitors and inductors (Direct analogy)



Interconnected patches enable multimodal damping

Array of piezoelectric patches → No external capacitors

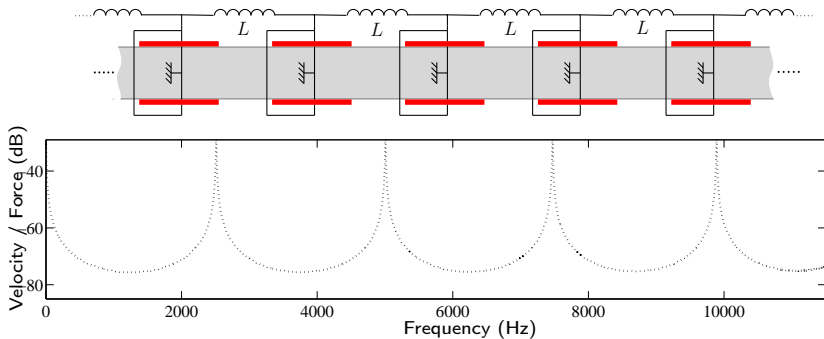


Same dispersion relations + Analogous boundary conditions

→ "Multimodal tuned mass damper"

Interconnected patches enable multimodal damping

Array of piezoelectric patches → No external capacitors

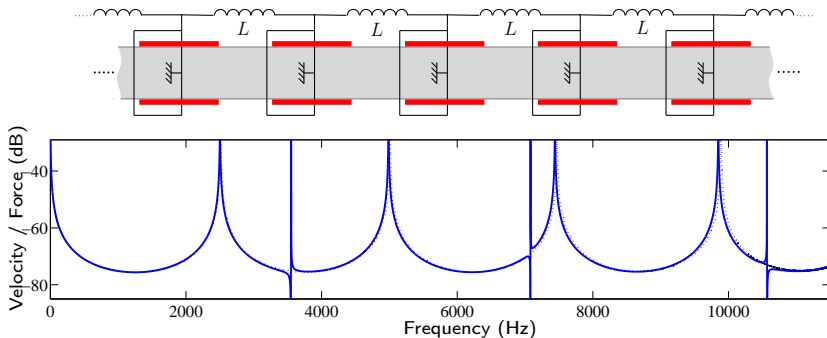


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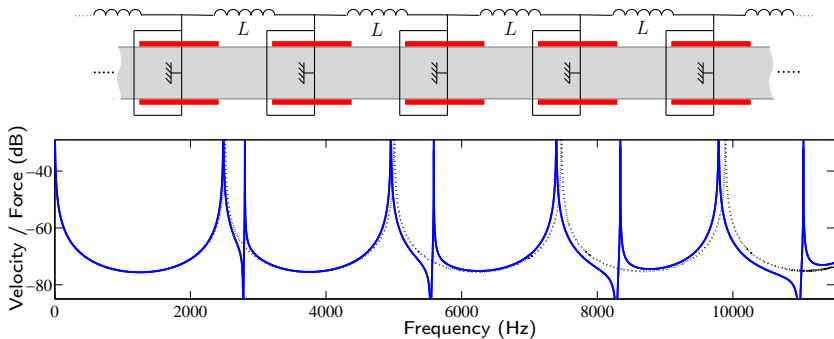


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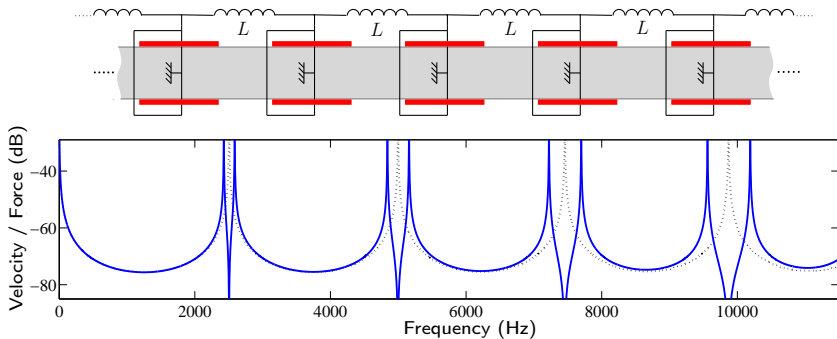


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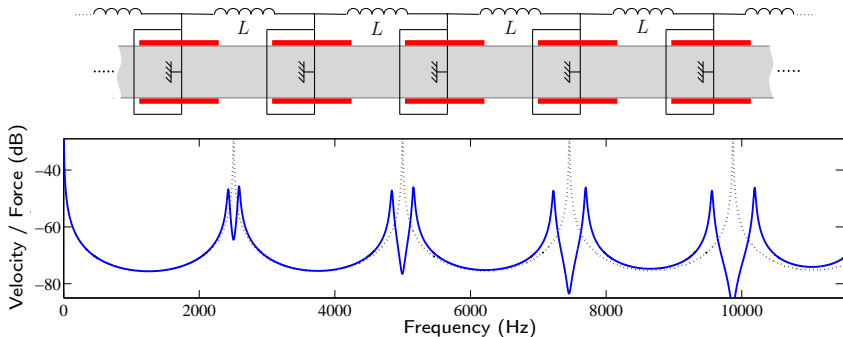


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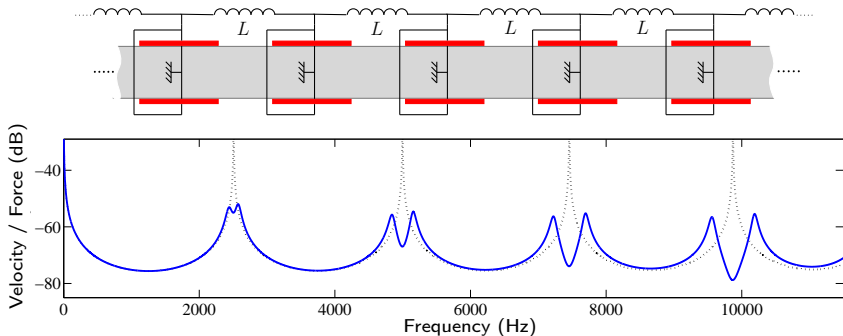


Same dispersion relations + Analogous boundary conditions

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Interconnected patches enable multimodal damping

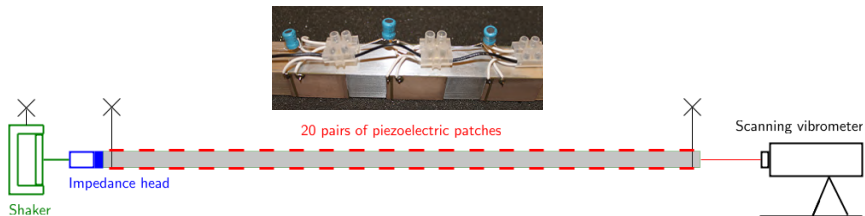
Array of piezoelectric patches → No external capacitors



Same dispersion relations + Analogous boundary conditions

→ **"Multimodal tuned mass damper"**

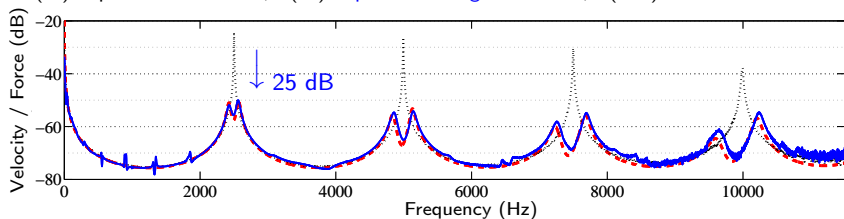
Models have been validated through experiments



First experimental validation of the control strategy

→ B. Lossouarn, M. Aucejo, J.-F. Deü, *Smart Materials & Structures*, 2015

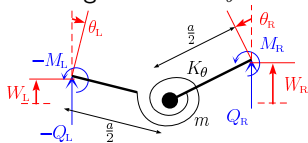
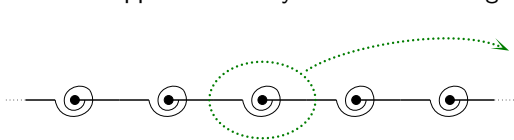
(...) Exp. without network, (—) Exp. with analogous network, (---) Transfer matrix model



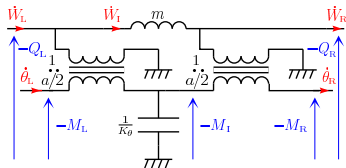
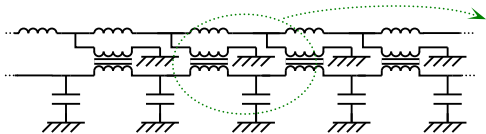
Discrete model for a beam

Same method: **Discrete model** + **Direct electromechanical analogy**

Beam approximated by a lattice involving the bending stiffness K_θ

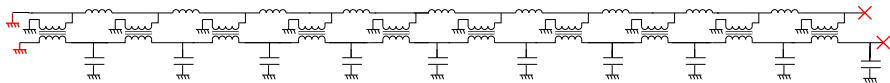


Analogous network with capacitors, inductors and transformers



Implementation of the analogous network

Analogous boundary conditions: Free = Short circuit, Clamped = Open circuit



Design of **inductors** and **transformers** + Capacitors from standard series

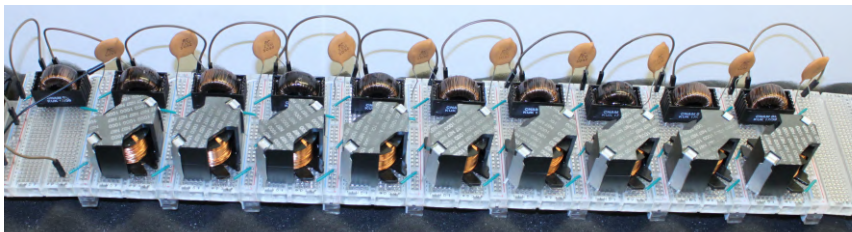
⇒ 9 ×



+ 10 ×

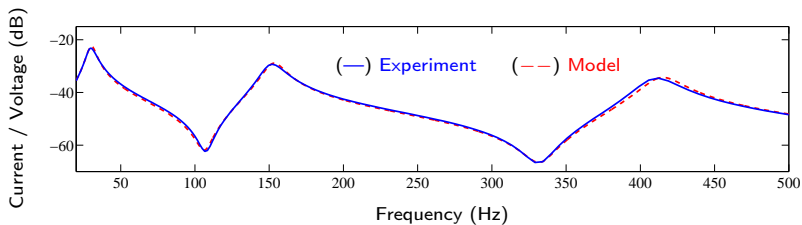
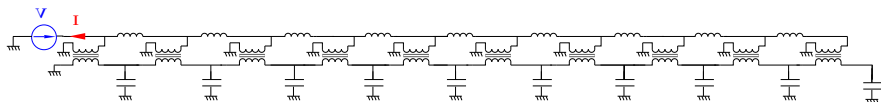


+ 10 ×



Analogous electrical network for a beam

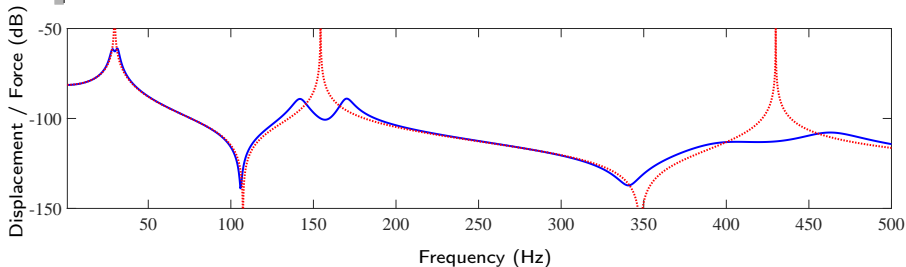
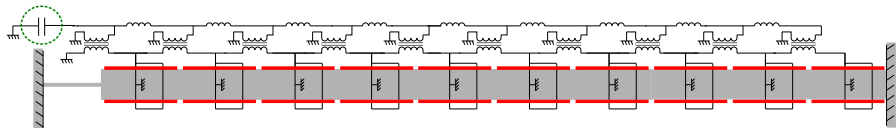
Admittance measurement at the "free end" of the electrical network



→ **Experimental modal analysis** of an electrical analogue

Broadband damping in the linear regime

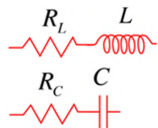
Analogous end capacitor : $v = \frac{1}{C_L} q$ where $C_L = \frac{K_\theta}{K_L} \frac{\hat{a}^2}{a^2} C_P$



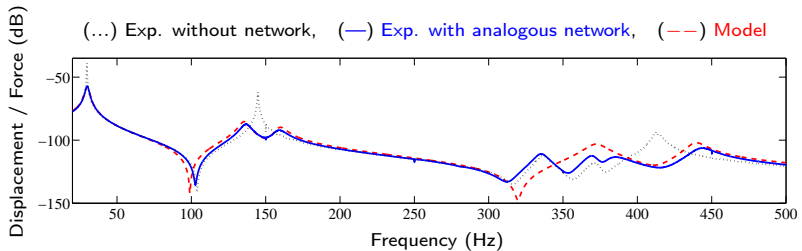
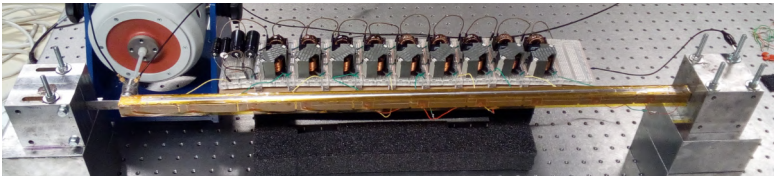
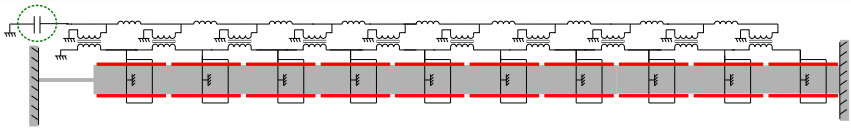
Optimal resistance for broadband damping ?

Lowest mode $\Rightarrow Z_L = j\omega L + R_L$

Highest mode $\Rightarrow Z_C = \frac{1}{j\omega C} + R_C$



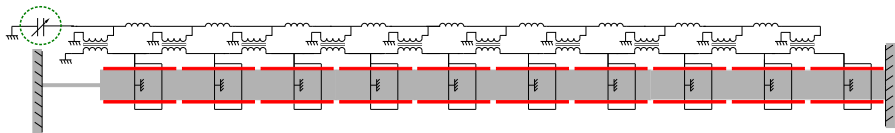
Electromechanical coupling through piezoelectric patches



→ **Multimodal damping** observed on the mechanical response

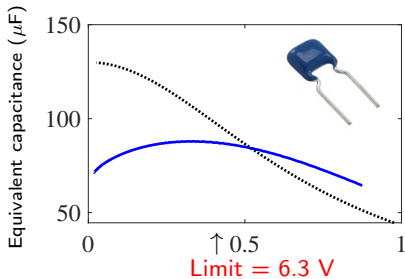
Toward a multimodal and nonlinear analogue

Variable electrical resonance due to variable capacitance

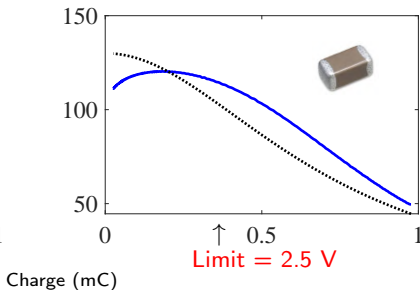


Nonlinear capacitor : $v = \frac{1}{C_L} q + \frac{1}{C_{NL}} q^3 \Rightarrow C(Q) \approx \frac{1}{\frac{1}{C_L} + \frac{3Q^2}{4C_{NL}}}$

→ Solution = **Multilayer Ceramic Capacitor**



Limit = 6.3 V



Limit = 2.5 V

Extension to multimodal damping of plates

Kirchhoff-Love theory

$$-D \left(\frac{\partial^4 w}{\partial x^4} + 2 \frac{\partial^4 w}{\partial x^2 \partial y^2} + \frac{\partial^4 w}{\partial y^4} \right) = \rho h \frac{\partial^2 w}{\partial t^2} \Leftrightarrow$$

$$\begin{cases} \frac{\partial Q_x}{\partial x} + \frac{\partial Q_y}{\partial y} = -\rho h a \omega^2 W \\ Q_i = -\frac{\partial M_i}{\partial i}, \quad i = x, y \\ M = aD \left(\frac{\partial \theta_x}{\partial x} + \frac{\partial \theta_y}{\partial y} \right) \\ \theta_i = \frac{\partial W}{\partial i}, \quad i = x, y \end{cases}$$

→ New system of equations with
internal state variables Q , M and θ

Finite difference method based on a square plate unit cell



$$\begin{aligned} Q_R - Q_L + Q_T - Q_B &= -m\omega^2 W_I \\ M_I &= D(\theta_R - \theta_L + \theta_T - \theta_B) \end{aligned}$$

+ Discrete derivatives

Extension to multimodal damping of plates

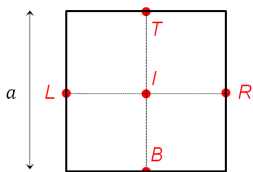
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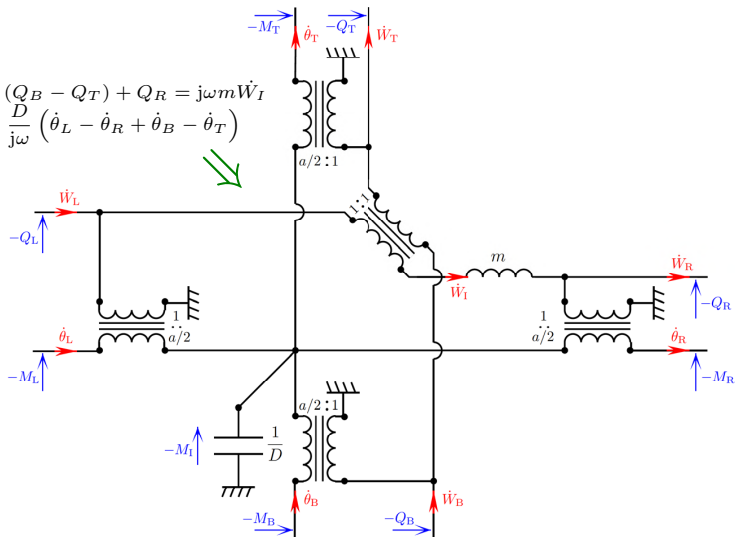
+ Discrete derivatives

Obtain the analogous electrical topology

Direct electromechanical analogy: Force = Voltage and Velocity = Current

$$-Q_L - (Q_B - Q_T) + Q_R = j\omega m \dot{W}_I$$

$$-M_I = \frac{D}{j\omega} (\dot{\theta}_L - \dot{\theta}_R + \dot{\theta}_B - \dot{\theta}_T)$$

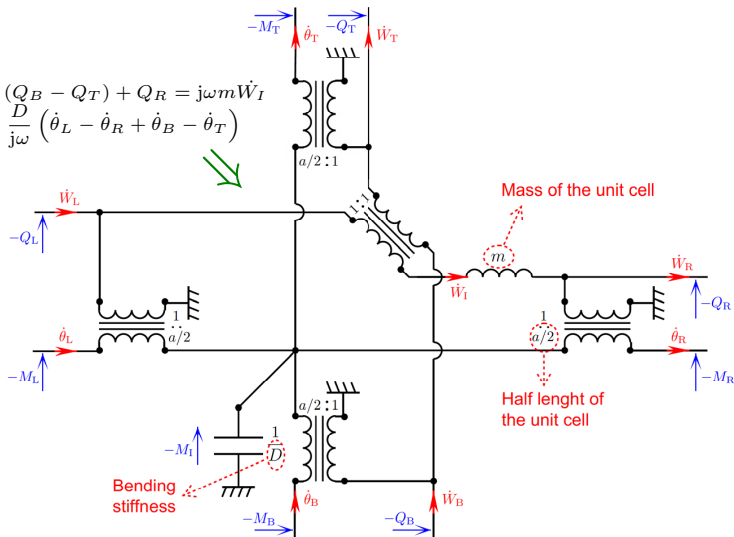


Obtain the analogous electrical topology

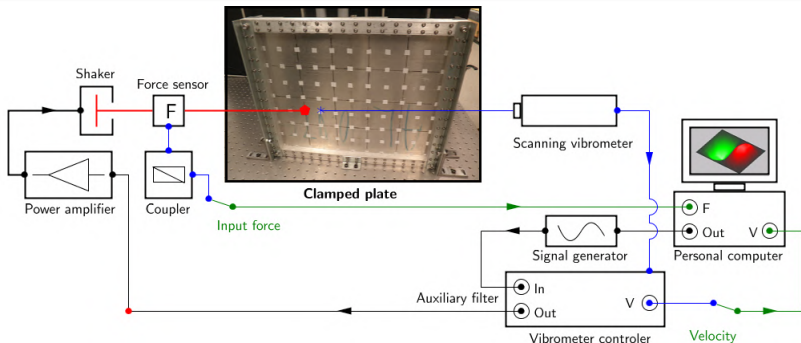
Direct electromechanical analogy: Force = Voltage and Velocity = Current

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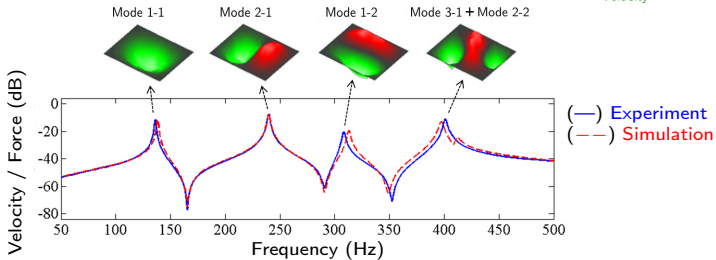
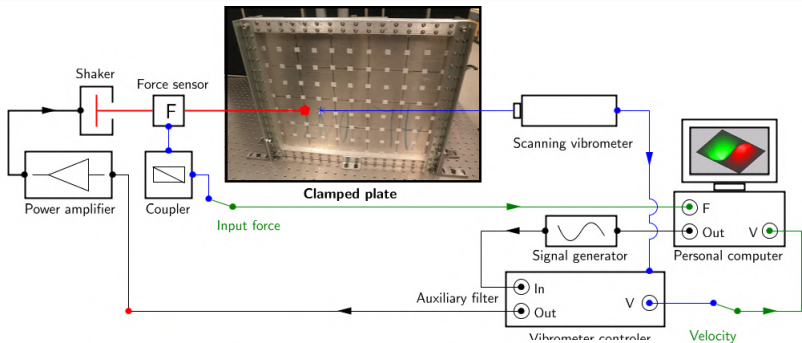
$$-M_I = \frac{D}{j\omega} (\dot{\theta}_L - \dot{\theta}_R + \dot{\theta}_B - \dot{\theta}_T)$$



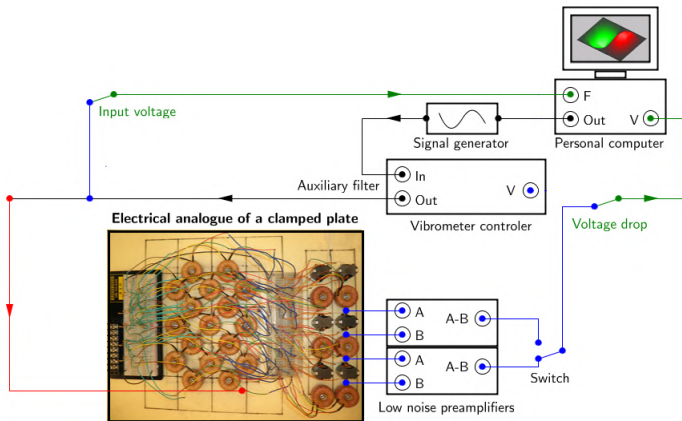
The network approximates the dynamics of a clamped plate



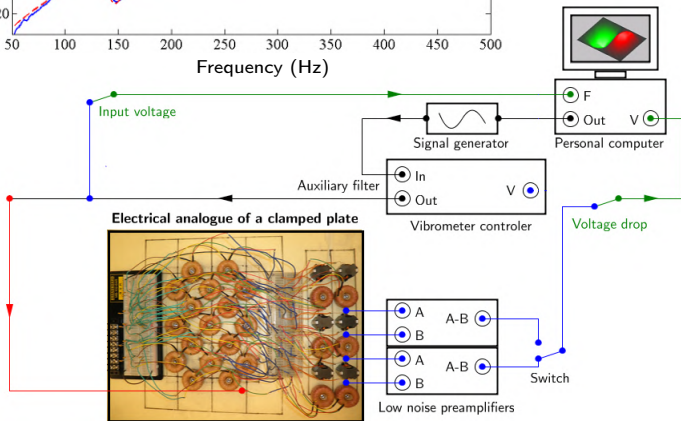
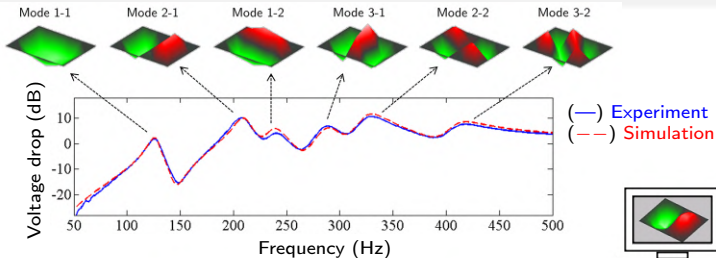
The network approximates the dynamics of a clamped plate



The network approximates the dynamics of a clamped plate



The network approximates the dynamics of a clamped plate



Vacuum bonding process

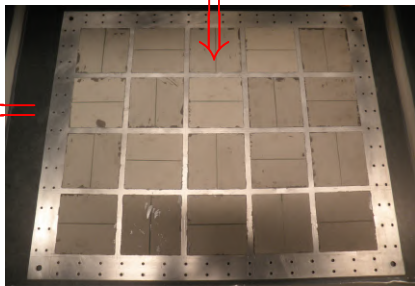
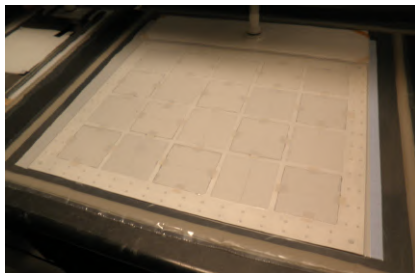
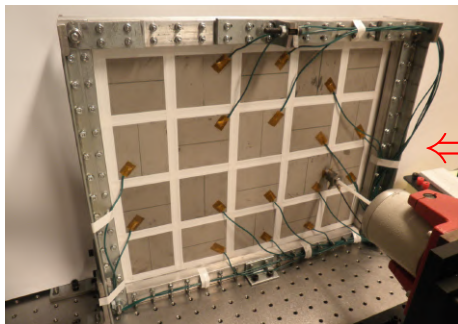
Aluminum plate

400×320 mm², 1.9 mm thick

20 PZT-5H square sheets

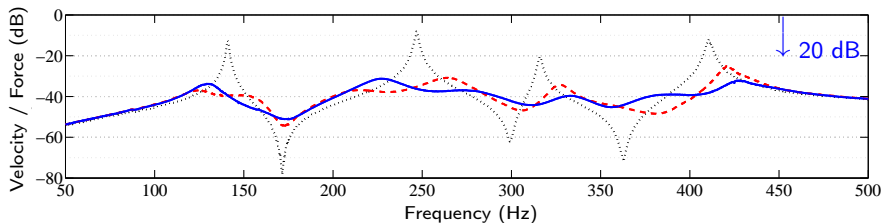
72.4×72.4 mm², 0.27 mm thick

3M DP460 two-part epoxy



Analogous coupling generates broadband vibration reduction

(...) Exp. without network, (---) Exp. with $L = 0.9$ H, (—) Exp. with $L = 0.7$ H



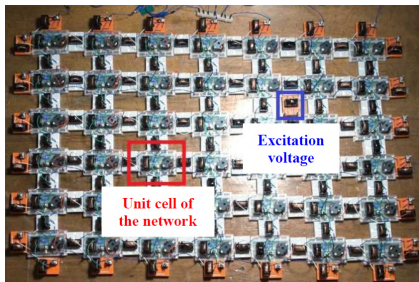
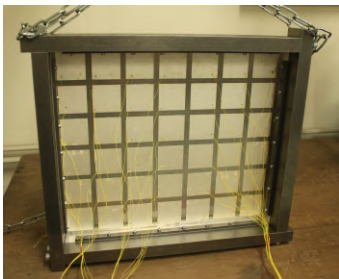
→ Experimental validation of the electromechanical model

→ **Multimodal tuned mass damping**

Broadband control of a continuous plate with a discrete network

Last plate setup at Cnam (see Robin Darleux...)

Simply supported plate coupled to its analogous electrical network



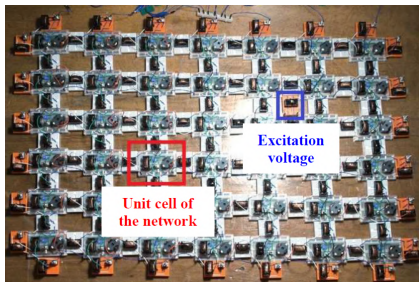
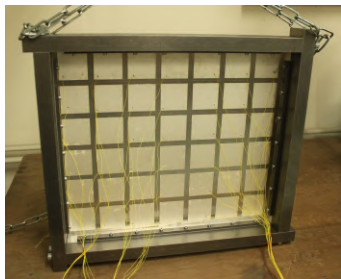
Current work

- Non-periodic and complex structures
- Comparison with viscoelastic treatments



Last plate setup at Cnam (see Robin Darleux...)

Simply supported plate coupled to its analogous electrical network



Current work

- **Non-periodic** and complex structures
- Comparison with **viscoelastic treatments**



Outline

- 1 Laboratoire de Mécanique des Structures et des Systèmes Couplés
- 2 Piezoelectric tuned vibration absorber
- 3 Finite element models and optimization for complex structures
- 4 Environmental parameters: beyond the linear shunt
- 5 Multimodal vibration damping
- 6 Conclusions and perspectives**

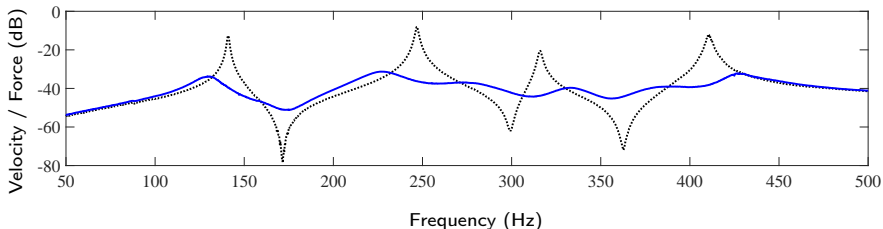
Passive damping with piezoelectric networks

Numerical models for complex electromechanical structures



Experimental validations

- Multimodal damping with resonant electrical networks
- **Passive, broadband and robust control strategy**



- **Strong potential** for industrial applications

Thank you for your attention !

boris.lossouarn@lecnam.net